LIST OF PUBLICATIONS  
CITED BY APPLICANTAtty Docket No.  
SEL 219Serial No.  
09/684,568

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Applicant  
Yukio Tanaka

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GROUP 3600

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October 6, 2000Group  
2675

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
ZRY	5,323,042	06/21/94	Matsumoto	257	350	11/13/92
	5,693,959	12/02/97	Inoue et al	257	66	04/10/96
	6,180,957 B1	01/30/01	Miyasaka et al	257	57	04/08/97
	6,259,138 B1	07/10/01	Ohtani et al	257	351	12/16/99
	6,365,917 B1	04/02/02	Yamazaki	257	72	11/16/99
	6,420,758 B1	07/16/02	Nakajima	257	350	11/16/99
	6,469,317 B1	10/22/02	Yamazaki et al	257	59	12/16/99
	6,501,098 B2	12/31/02	Yamazaki	257	72	11/23/99
	6,512,271 B1	01/28/03	Yamazaki et al	257	350	11/16/99
	6,518,594 B1	02/11/03	Nakajima et al	257	59	11/16/99
	6,524,895 B2	02/25/03	Yamazaki et al	438	149	12/23/99
	6,531,713 B1	03/11/03	Yamazaki	257	59	03/17/00
	6,576,924 B1	06/10/03	Yamazaki et al	257	59	02/07/00
	6,576,926 B1	06/10/03	Yamazaki et al	257	66	02/22/00

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE
ZRY	JP 3-250632	11/08/91	Seiko Epson Corp.	X		10/02/90
	JP 4 369271	12/22/92	Casio Computer Co.	X		06/17/91
	JP 5-102483	04/23/93	Sharp KK	X		10/09/91
	JP 10-144929	05/29/98	Semiconductor	X		11/12/96
	EP 1 001 467 A2	05/17/00	Energy Lab Co. Ltd Semiconductor Energy Lab Co. Ltd			11/09/99

## OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

(Include name of author (in CAPITAL LETTERS), title of article or item (book, magazine, journal, serial, symposium, catalog, etc.) date, pages(s), volume-issue number(s), publisher, city and/or country where published).

EXAMINER:

*Leland R. Jensen*

DATE CONSIDERED:

2/23/04



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	<u>Applicant</u> Yukio Tanaka	
	<u>Filing Date</u> October 6, 2000	<u>Group</u> 2675

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE
LRA	EP 1 005 093	05/31/00	Semiconductor			11/19/99
LRA	A2		Energy Lab Co. Ltd			
	EP 1 005 094	05/31/00	Semiconductor			11/24/99
	A2		Energy Lab Co. Ltd			
LRA	EP 1 028 469	08/16/00	Semiconductor			02/11/00
	A2		Energy Lab Co. Ltd			
LRA	EP 1 031 873	08/30/00	Semiconductor			02/22/00
	A2		Energy Lab Co. Ltd			
LRA	EP 1 033 755	09/06/00	Semiconductor			03/03/00
	A2		Energy Lab Co. Ltd			
LRA	EP 1 041 641	10/04/00	Semiconductor			03/16/00
	A2		Energy Lab Co. Ltd			

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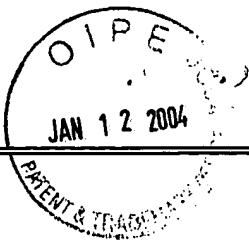
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EXAMINER: <i>David R. Sommer</i>	DATE CONSIDERED: <i>2/23/04</i>
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.	

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	<del>5,323,042</del>	<del>06/21/94</del>	<del>Matsumoto</del>	<del>257</del>	<del>350</del>	<del>11/13/92</del>
	<del>5,693,959</del>	<del>12/02/97</del>	<del>Inoue et al</del>	<del>257</del>	<del>66</del>	<del>04/10/96</del>
	<del>6,180,957 B1</del>	<del>01/30/01</del>	<del>Miyasaka et al</del>	<del>257</del>	<del>57</del>	<del>04/08/97</del>
	<del>6,259,138 B1</del>	<del>07/10/01</del>	<del>Ohtani et al</del>	<del>257</del>	<del>351</del>	<del>12/16/99</del>
	<del>6,365,917 B1</del>	<del>04/02/02</del>	<del>Yamazaki</del>	<del>257</del>	<del>72</del>	<del>11/16/99</del>
	<del>6,420,758 B1</del>	<del>07/16/02</del>	<del>Nakajima</del>	<del>257</del>	<del>350</del>	<del>11/16/99</del>
	<del>6,469,317 B1</del>	<del>10/22/02</del>	<del>Yamazaki et al</del>	<del>257</del>	<del>59</del>	<del>12/16/99</del>
	<del>6,501,098 B2</del>	<del>12/31/02</del>	<del>Yamazaki</del>	<del>257</del>	<del>72</del>	<del>11/23/99</del>
	<del>6,512,271 B1</del>	<del>01/28/03</del>	<del>Yamazaki et al</del>	<del>257</del>	<del>350</del>	<del>11/16/99</del>
	<del>6,518,594 B1</del>	<del>02/11/03</del>	<del>Nakajima et al</del>	<del>257</del>	<del>59</del>	<del>11/16/99</del>
	<del>6,524,895 B2</del>	<del>02/25/03</del>	<del>Yamazaki et al</del>	<del>438</del>	<del>149</del>	<del>12/23/99</del>
	<del>6,531,713 B1</del>	<del>03/11/03</del>	<del>Yamazaki</del>	<del>257</del>	<del>59</del>	<del>03/17/00</del>
	<del>6,576,924 B1</del>	<del>06/10/03</del>	<del>Yamazaki et al</del>	<del>257</del>	<del>59</del>	<del>02/07/00</del>
	<del>6,576,926 B1</del>	<del>06/10/03</del>	<del>Yamazaki et al</del>	<del>257</del>	<del>66</del>	<del>02/22/00</del>

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	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE
<i>28/2</i>	<del>JP 3-250632</del>	<del>11/08/91</del>	<del>Seiko Epson Corp.</del>	<del>X</del>		<del>10/02/90</del>
	<del>JP 4-369271</del>	<del>12/22/92</del>	<del>Casio Computer Co.</del>		<del>X</del>	<del>06/17/91</del>
	<del>JP 5-102483</del>	<del>04/23/93</del>	<del>Sharp KK</del>		<del>X</del>	<del>10/09/91</del>
	<del>JP 10-144929</del>	<del>05/29/98</del>	<del>Semiconductor</del>	<del>X</del>		<del>11/12/96</del>
			<del>Energy Lab Co. Ltd</del>			
	<del>EP 1 001 467</del>	<del>05/17/00</del>	<del>Semiconductor</del>			<del>11/09/99</del>
	A2		Energy Lab Co. Ltd			

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EXAMINER:

*Lland R. Jensen*

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